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United States Patent [19]

Kadomura et al.

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[54]	METHOD AND APPARATUS FOR DRY ETCHING WITH TEMPERATURE CONTROL		
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[73]	Assignee: Sony Corporation, Tokyo, Japan		
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Feb. 26, 1996 [JP] Japan 8-037691 Mar. 4, 1996 [JP] Japan 8-045868			
[51]	Int. Cl. ⁷ H01L 21/302		
	U.S. Cl.		
[58]			
	438/714, 715, 733, 738		
[56]	References Cited		
U.S. PATENT DOCUMENTS			

4,971,653 11/1990 Powell et al. 216/59

 5,320,982
 6/1994
 Tsubone et al.
 437/228

 5,584,971
 12/1996
 Komino
 216/59

 5,605,600
 2/1997
 Muller et al.
 216/67

5,681,780	10/1997	Mihara et al 437/228
5,711,851	1/1998	Blalock et al 156/643.1
5,900,105	5/1999	Toshima 156/345
5,900,162	5/1999	Kawahara et al 216/67
5,928,964	7/1999	Brankner 437/711
5,981,913	11/1999	Kadomura et al 219/444.1
6,004,882	12/1999	Kim et al 438/706
6,008,133	12/1999	Kumihashi et al 216/67

FOREIGN PATENT DOCUMENTS

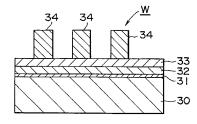
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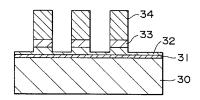
Primary Examiner—Randy Gulakowski Assistant Examiner—Anita Alanko Attorney, Agent, or Firm—Hill & Simpson

[57] ABSTRACT

A method of dry etching treatment capable of attaining both high selectivity and fine fabrication at a high accuracy simultaneously is provided, in which an etching treatment comprising a plurality of steps are applied to a specimen W in one identical processing apparatus, and the temperature of the specimen is changed between etching of one step and etching of another step succeeding thereto, among the plurality of the steps, thereby applying etching at temperatures different between the one step and the step succeeding thereto.

16 Claims, 4 Drawing Sheets





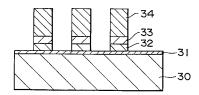




FIG. IA

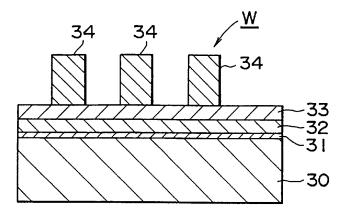


FIG. IB

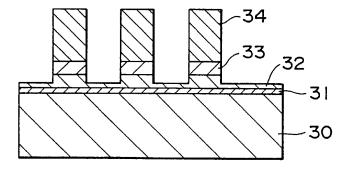


FIG. IC

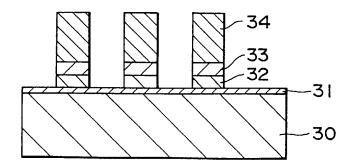
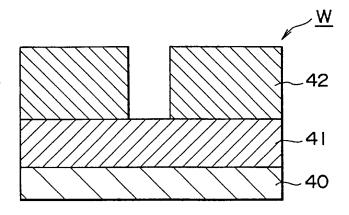


FIG. 2A



F I G. 2B

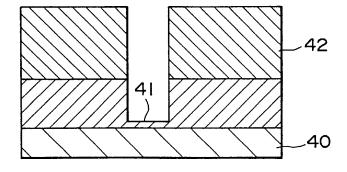


FIG. 2C

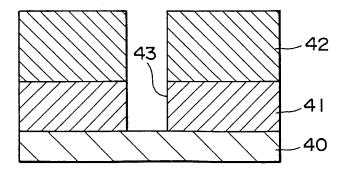
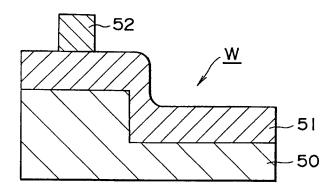


FIG. 3A



F I G. 3B

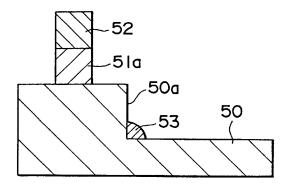
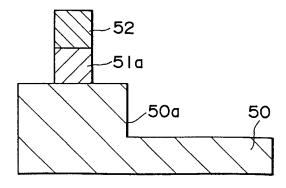
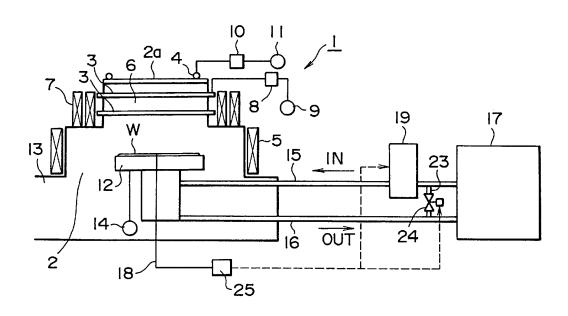


FIG. 3C

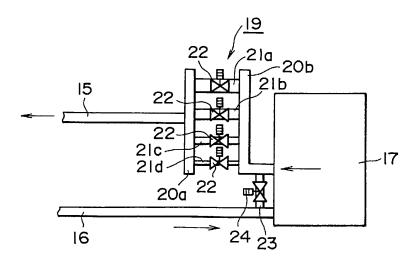


F I G. 4

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F I G. 5



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